

DECONTAMINATION OF POWDER DIFFRACTION DATA MEASURED WITH COPPER $K\alpha$ X-RAY AND NICKEL FILTER

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One-dimensional X-ray detector has become widely used in laboratory powder diffraction measurement. We have analyzed the diffraction data from standard Si (NIST SRM640c) and LaB₆ (NST SRM660a) powder samples collected with a combination of a Cu $K\alpha$ X-ray tube, a flat powder specimen, a Ni foil $K\beta$ filter, a couple of Soller slits and a one-dimensional detector arranged in Bragg-Brentano geometry.

The deconvolution-convolution method [1] has been improved to remove the shift and deformation caused by axial-divergence aberration more precisely than the previous method [2]. It has been found that the contribution of white X-ray emitted from the tube should be taken into account to simulate the step structure caused by Ni K-absorption edge [3]. Cu $K\alpha_2$, Cu $K\beta$ and Ni K-absorption edge structures and unidentified four series of small peaks (a), (b), (c), (d) marked in Figure 1 have effectively been removed by the current deconvolution-convolution method applying a realistic spectroscopic profile model of the source X-ray. Origins of peaks (a)–(d) are not fully identified, but they are likely to be caused by contamination of tungsten and nickel in the X-ray tube.

References:

- [1] Ida, T. and Toraya, H. (2012). *J. Appl. Crystallogr.* 35, 58–68.
- [2] Ida, T., Ono S., Hattan, D., Yoshida, T., Takatsu Y. and Nomura, K. (submitted) *Powder Diffraction*.
- [3] Ida, T., Ono S., Hattan, D., Yoshida, T., Takatsu Y. and Nomura, K. (submitted) *Powder Diffraction*.

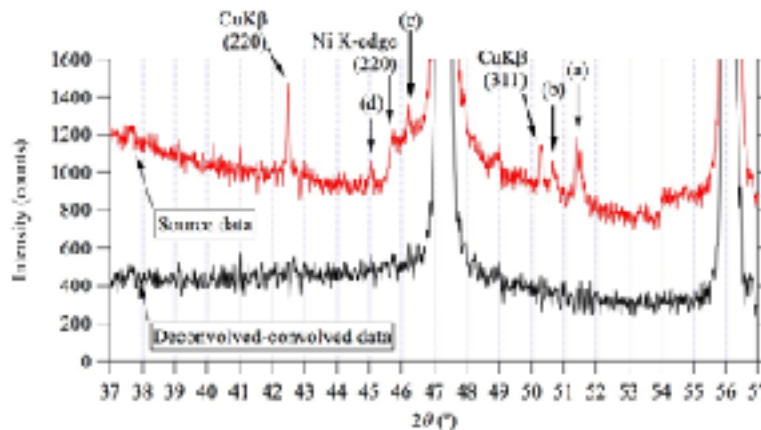


Figure 1 Magnified plots of the observed and deconvolved-convolved powder diffraction data of Si.